


Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		 ATTY DOCKET NO. 278591US0PCT		SERIAL NO. 10/549,848	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Atsushi IWATA, et al.		GROUP 1792	
				FILING DATE September 19, 2005			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	55-056004	04/24/80	JP (with English abstract)		NO	
	AP	58-204809	11/29/83	JP (with English abstract)		NO	
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	AKEWATASHI, Jun et al., Ceramic Thin Film Formation Technology Using Collision and Solidification Phenomena of Particles and Ultra-fine Particles.- Aerosol Deposition Method for High Speed Coating at Low Temperature, National Institute of Advanced Industrial Science and Technology, Tsukuba, Pages 459 - 466, 2002, with Partial English Translation.					
	AX	KIM, I.W. et al., Critical Thickness for Transformation of Epitaxially Stabilized Cubic AlN in Superlattices, Applied Physics Letters, Vol. 78, No. 7, Pages 892 - 894, 2001.					
	AY	MASHIMO, Tsutomu et al., Yield Properties, Phase Transition, and equation of State of Aluminum Nitride (AlN) Under Shock Compression up to 150 GPa., Journal of Applied Physics, Vol. 86, No. 12, Pages 6710 - 6716, 1999.					
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner /Felisa Hitesheiw/					Date Considered 04/18/2008		

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /F.H./



U.S. PCT Application Serial No: 10/549,848  
Filed: September 19, 2005  
Atsushi IWATA, et al.  
Docket No. 278591 US

STATEMENT OF RELEVANCY

- 1) References AO - AP have been cited in the International Search Report. A copy of these references is being submitted herewith.
- 2) References            have been cited in the corresponding            Search Report. A copy of these references is being submitted herewith.
- 3) References AW - AY are discussed in the specification. A copy of these references is being submitted herewith.
- 4) References            are additional prior art known to Applicant. A copy of these references is being submitted herewith.